

Electronic Acknowledgement Receipt

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Application Number:	10511883
International Application Number:	
Confirmation Number:	4213
Title of Invention:	Apparatus and method for depositing thin film on wafer using remote plasma
First Named Inventor/Applicant Name:	Young Hoon Park
Customer Number:	23413
Filer:	James J. Merrick/Shenita Carroll
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part /.zip	Pages (if appl.)
1	Amendment - After Non-Final Rejection	Response_to_Office_Action_YPL-0108.pdf	1077753	no	12

Warnings:

Information:					
2	Miscellaneous Incoming Letter	Marked_up_Specification_Y PL-0108.pdf	2158877	no	15
Warnings:					
Information:					
3	Miscellaneous Incoming Letter	Clean_Specification_YPL-01 08.pdf	2108737	no	15
Warnings:					
Information:					
Total Files Size (in bytes):			5345367		
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